

Notice of References Cited	Application/Control No. 10/685,674	Applicant(s)/Patent Under Reexamination KANEKO, SHINJI	
	Examiner John Juba, Jr.	Art Unit 2872	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	C	US-6,568,647	05-2003	Graves et al.	248/476
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NON-PATENT DOCUMENTS

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	U	Gleb Vdovin, et al., "Technology and applications oof micromachined silicon adaptive mirrors", Optical Engineering Vol. 36, no. 5, pp. 1382-1390, May 1997.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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